

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



In re Application of:)
SHINICHI HARA, ET AL.)
Application No.: 09/818,625)
Filed: March 28, 2001)
For: EXPOSURE APPARATUS, GAS)
REPLACEMENT METHOD,)
SEMICONDUCTOR DEVICE)
MANUFACTURING METHOD,)
SEMICONDUCTOR MANUFACTURING)
FACTORY, AND EXPOSURE)
APPARATUS MAINTENANCE)
METHOD :

Examiner: Not Assigned
Group Art Unit: 2851
June 28, 2001

Box Missing Parts
The Commissioner for Patents
Washington, D.C. 20231

REQUEST FOR CORRECTED FILING RECEIPT

Sir:

Applicants' attorneys have received an official Filing Receipt in the above-identified application in which the following has changed:

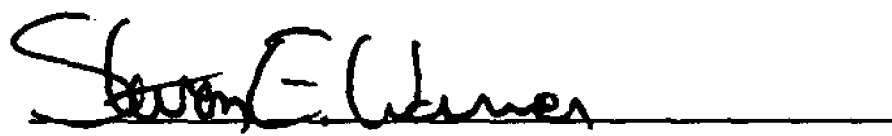
The Address of the Fourth Inventor, Toru HIRABAYASHI has changed from "Tokyo, Japan" to --Tochigi, Japan--.

Applicants request issuance of a corrected Filing Receipt, corrected as shown above, is accordingly respectfully requested.

The Commissioner is authorized to charge Deposit Account No. 06-1205 should any fees be deemed necessary for this correction. A duplicate of this paper is enclosed for this purpose.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,


Attorney for Applicants

Steven E. Warner
Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200

SEW\cmv